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Docket No.: 4590-500

1AP20 Rec'd PCT/PTO 24 APR 2000 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Elias BITAR et al.

U.S. Patent Application No.: -----

Filed: *herewith*

Confirmation No.

Group Art Unit: -----

For: METHOD FOR DETERMINING OPTIMAL CHAMFER MASK COEFFICIENTS FOR
DISTANCE TRANSFORM

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to examination of the above-referenced application, please amend the
application as follows: